

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

PATENT
RECEIVED
CENTRAL FAX CENTER

Applicant: MAJIMA et al.

Examiner: VO, Hai

FEB 18 2004

Serial No.: 09/890,550

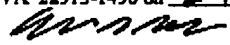
Group No.: 1771

Filed: January 14, 2002

OFFICIAL

Title: POROUS SILICON CARBIDE SINTER AND SILICON CARBIDE-METAL
COMPOSITE THAT ARE OPTIMAL FOR A WAFER GRINDER TABLERESPONSE TO OFFICE ACTIONCERTIFICATE OF TRANSMISSION/MAILING

I hereby certify that this correspondence is being resubmitted
transmitted to the USPTO or deposited with the United States
Postal Service with sufficient postage as first class mail in an
envelope addressed to: Commissioner for Patents, Alexandria,
VA 22313-1450 on 2-18-04.


Reg. No. 40,764
Mark D. Passler

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

INTRODUCTORY COMMENTS

In reply to the Office Action dated August 18, 2003 in the above-identified application,
please enter the following Response.

Remarks/Arguments begin on page 2 of this paper.